

SUPPORTING INFORMATION

Chemical Bath Deposition of Aluminum Oxide Buffer on Curved Surfaces for Growing Aligned Carbon Nanotube Arrays

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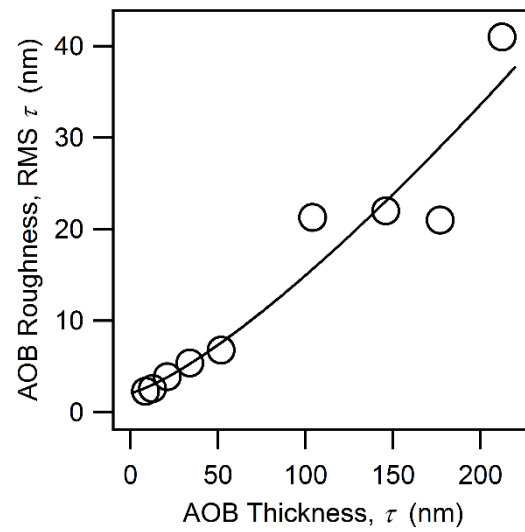


Figure S1. Increase of surface roughness with the increase of the thickness of aluminum oxide buffer (AOB) layer. The solid curve is a fit to a power function (root mean square RMS = $2.15 + 0.033 \tau^{1.29}$; $R^2 = 0.91$).